

DECLARATION

As the below-named inventor, I declare that:

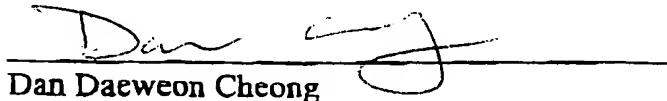
My residence, post office address, and citizenship are as stated below under my name.

I believe I am the original, first, and sole inventor of the subject matter claimed and for which a patent is sought on the invention entitled "MULTIPLE SOURCE DEPOSITION PROCESS," the specification of which was filed in the U.S. Patent and Trademark Office on December 22, 2000 and assigned application number 09/747,315, confirmation number 1283 (Attorney Docket No. 35682-8001US).

I have reviewed and understand the contents of the above-identified specification and claims, as amended by any amendment specifically referred to above.

I acknowledge my duty to disclose information which is material to the patentability of this application in accordance with 37 C.F.R. § 1.56(a).

I further declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further, that these statements were made with the knowledge that the making of willfully false statements and the like is punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and may jeopardize the validity of any patent issuing from this patent application.



Dan Daeweon Cheong

Date January 25, 2001

Residence : City of Mississauga

Country of Canada

Citizenship : Canadian

P.O. Address : 806 Crawford Mill Avenue

Mississauga L5W 1B5, Ontario, Canada